	Application No.	Applicant(s)
Notice of Allowability	10/050,499	SINGH ET AL.
	Examiner	Art Unit
	DAVID VU	2818
The MAILING DATE of this communication appears on the cover sheet with the correspondence address All claims being allowable, PROSECUTION ON THE MERITS IS (OR REMAINS) CLOSED in this application. If not included herewith (or previously mailed), a Notice of Allowance (PTOL-85) or other appropriate communication will be mailed in due course. THIS NOTICE OF ALLOWABILITY IS NOT A GRANT OF PATENT RIGHTS. This application is subject to withdrawal from issue at the initiative of the Office or upon petition by the applicant. See 37 CFR 1.313 and MPEP 1308. 1. This communication is responsive to 01/12/04.		
2. The allowed claim(s) is/are <u>1-19</u> .		
3. The drawings filed on 16 January 2002 are accepted by the Examiner.		
4.		
	6. Interview Su Paper No./ 08), 7. Examiner's	formal Patent Application (PTO-152) Immary (PTO-413), Mail Date Amendment/Comment Statement of Reasons for Allowance
Technology Center 2800		

DETAILED ACTION

Reason for allowance

1. The following is an examiner's statement of reason for allowance: None of the references of record teaches or suggests a system for depositing films on a semiconductor wafer comprising: a deposition chamber operable to deposit a film on the semiconductor wafer therein according to one or more process conditions; an acoustic microbalance within the deposition chamber; and a controller, wherein the controller is configured to provide feedback control of the one or more process conditions based on data provided at least in part by the acoustic microbalance.

Any comments considered necessary by applicant must be submitted no later than the payment of the issue fee and, to avoid processing delays, should preferably accompany the issue fee. Such submissions should be clearly labeled "Comments on Statement of Reasons for Allowance".

Conclusion

2. Any inquiry concerning this communication or earlier communications from the examiner should be directed to David Vu whose telephone number is 571-272-1798. The examiner can normally be reached on Monday-Friday 8:00am-5:30 pm. If attempts to reach the

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examiner by telephone are unsuccessful, the examiner's supervisor, David Nelms can be reached on 571-272-1787. The fax phone numbers for the organization where this application or proceeding is assigned are (703) 308-7722 for regular communications and (703) 308-7722 for After Final communications. Any inquiry of a general nature or relating to the status of this application or proceeding should be directed to the receptionist whose telephone number is (703) 308-0956.

DV

David Vu.

Supervisory Patent Examiner
Technology Center 2800